



**ELECTRONIC COPY**

**LABORATORY GROWN DIAMOND REPORT**

February 19, 2026  
IGI Report Number **LG775630884**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **OVAL BRILLIANT**  
Measurements **11.13 X 7.62 X 4.47 MM**

**GRADING RESULTS**

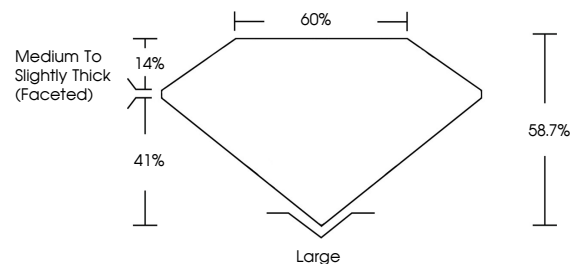
Carat Weight **2.54 CARATS**  
Color Grade **E**  
Clarity Grade **VS 1**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG775630884**

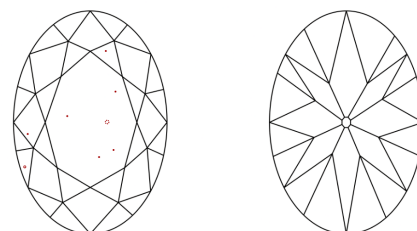
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

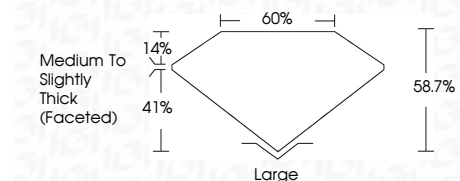
D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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**OVAL BRILLIANT**  
11.13 X 7.62 X 4.47 MM  
Carat Weight **2.54 CARATS**  
Color Grade **E**  
Clarity Grade **VS 1**  
Depth **58.7%**  
Table **14%**  
Girdle **Medium to Slightly Thick (Faceted)**  
Culet **Large**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
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